



NOTES/SPECIFICATIONS:

- DESIGN WAVELENGTH RANGE: 333-364nm CLEAR APERTURE: > Ø 15.2mm DIAMETER TOLERANCE: $\pm 0.0/-0.1$ mm THICKNESS TOLERANCE: ± 0.2 mm SURFACE QUALITY (S1): 10-5 SCRATCH-DIG SURFACE (S2): FINE GROUND SURFACE FLATNESS (S1): $< \lambda/10$ AT 633nm PARALLELISM: < 3 arcmin 1.

- 2. 3. 4. 5. 6. 7. 8.
- COATING (S1): REFLECTIVE COATING AT 352nm R>99.5%, AOI = 0° 9. Rs>99.0%, Rp>98.7, AOI =45°

FOR INFORMATION ONLY NOT FOR MANUFACTURING PURPOSES

DRAWING PROJECTION			THOR ABS www.thorlabs.com		
	NAME	DATE	Ø19.0mm AR-ION LASER LINE		E
DRAWN	GG	10/MAR/16	MIRROR, 333-364nm		
APPROVAL	DD	10/MAR/16	MATERIAL FUSED SILICA		REV
COPYRIGHT © 2016 BY THORLABS					Α
VALUES IN PARENTHESIS ARE CALCULATED AND MAY CONTAIN ROUNDOFF ERRORS			EM # APPROX WE NB07-K07 3 g		IGHT